

Notice of References Cited	Application/Control No. 10/721,448	Applicant(s)/Patent Under Reexamination BRASK ET AL.	
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	C	US-6,224,713	05-2001	Hembree et al.	156/345.11
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NON-PATENT DOCUMENTS

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	U	Wolf et al., Silicon Processing for the VLSI Era, 1986, Lattice Press, Vol. 1, pp. 519, 529-30, 534, 551.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.